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Substitute for Form 1449 A & B/PTO				Application Number Confirmation Number Filing Date First Named Inventor Art Unit Examiner Name Attorney Docket Number	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Based on PCT/GB2004/000161 Unknown July 18, 2005 Henning SIRRINGHAUS Unknown 2813 Unknown Blum Q89250	
Sheet	1	of	1		

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US 2002/119584	A1	08-29-2002	Gregg Duthaler, et al.
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
		WO	01/46987	A	06-28-2001	PLASTIC LOGIC LTD	

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		KAWASE, T. et al., "All-Polymer Thin Film Transistors Fabricated by Inkjet Printing", Proceedings of the SPIE, SPIE, Bellingham, VA, US Vol. 4466, July 29, 2001, Pages 80-88, XP008006102, ISSN: 0277-786X	
		CHABINYC MICHAEL L, et al., "Organic Polymeric Thin-film Transistors Fabricated by Selective Dewetting", Applied Physics Letters, American Institute of Physics, New York, US, Vol. 81, No. 22, November 25, 2002, 4260-4262, XP012032662, ISSN: 0003-6951	
		ZHANG, J. et al., Investigation of Using Contact and Non-contact Printing Technologies For Organic Transistor Fabrication, Material Research Society Symposium Proceedings, Materials Research Society, Pittsburgh, PA, US, Vol. 725, April 1, 2002, Pages 155-160, XP008020720, ISSN: 0272-9172	
		PEDE, D., et al., Microfabrication of Conducting Polymer Devices by Ink-jet Stereolithography", Materials Science and Engineering C, Elsevier Science S.A, CH, Vol. C05, No. 3/4, February 1998, pages 289-291, XP000828177, ISSN: 0928-4931	

Examiner Signature	/David Blum/	Date Considered	12/15/2009
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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /D.B./

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